

107509303 #2

Dist Rec'd PCT/PTO 24 SEP 2004

7272-137 / 10410482

EV 323473611US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Satoshi AOKI

Serial No.: Unknown

Filed: Herewith

For: COMPOUND SEMICONDUCTOR
THIN-LAYER SOLAR CELL AND
METHOD OF FABRICATING THE SAME

) **Group Art Unit:** Unknown

) **Examiner:** Unknown

) **National Phase Entry of**
) **PCT/JP03/03500**

INFORMATION DISCLOSURE STATEMENT

MAIL STOP / IDS

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Applicant(s) hereby disclose to the Patent Office patents, publications or other information of which they are aware, that they believe may be material to the patentability of one or more of the pending claims in this application and in respect of which there may be a duty to disclose in accordance with 37 CFR 1.56.

The items identified in this Information Disclosure Statement may or may not be "material" pursuant to 37 CFR 1.56 and the submission thereof by Applicant(s) shall not be construed as an admission that any such patent, publication or other information referred to therein is material or considered to be material (37 CFR 1.97h), or even

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qualifies as "prior art" under 35 USC §102 with respect to this invention unless specifically designated by Applicant(s) as such.

The filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information, as defined in 37 CFR 1.56, exists.

Attached is PTO Form 1449 listing the patents, publications and other information that may be material to the patentability of one or more claims of the subject application and copies of all such items are enclosed herewith.

A "concise explanation of the relevance" of the non-English language reference(s), as required by 37 CFR § 1.98(a)(3), is set forth at the start of the specification of this application in the discussion of the prior art.

Since this Information Disclosure Statement is being filed with the application, no fee or certification is required under 37 CFR §1.97.

Respectfully submitted,

Fulbright & Jaworski LLP

Dated: Sept 24, '04

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ATTY. DOCKET NO.

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SERIAL NO.

1007509303

**LIST OF PATENTS AND OTHER INFORMATION FOR APPLICANT'S
INFORMATION DISCLOSURE STATEMENT**

APPLICANT:

Satoshi AOKI

FILING DATE:

September 24, 2004

GROUP:

Unknown

(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
	AA	4,611,091	9/1986	Choudary et al.	136	260	12/1984
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES NO
	AI	8-330614	1006	JP			Xx
	AJ						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	AK	"Study of Cd-free buffer layers using In _x (OH,S), on CIGS solar cells" by C.H. Huang et al., Solar Energy Materials & Solar Cells 69 (2001) 131-137
	AL	
	AM	
	AN	

EXAMINER:

/Shannon Gardner/

DATE CONSIDERED:

06/11/2008

EXAMINER: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /S.G./